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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	) Examiner: MacArthur, S.
Kurita, et al.	)
Serial No.: 09/464,362	) Art Unit: 1763
Filed: December 15, 1999	)
For: DUAL SUBSTRATE LOADLOCK	)
PROCESS EQUIPMENT	j

## TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sirs:

In accordance with 37 CFR §§ 1.56, 1.97, and 1.98, enclosed please find Form PTO-1449 listing the attached references which might be deemed material to the examination of the above-identified application.

## A. Non-English Language References

Enclosed is an foreign office action for a counterpart application. The search
report Examiner has provided comments on the relevancy of any non-English
language references cited in the office action.
The specification incorporates comments on the relevancy of Non-English
language references.
Set forth below are comments provided by the applicant's home country counse
on the relevancy of non-English language references:
An English language abstract has been submitted for the Japanese language
reference cited on Form PTO-1449